



Atty. Dkt. No. 041358-0270

IFC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Robert Nakayama *et al.*

Title: SENSOR FABRICATING
METHOD

Appl. No.: 09/847,885

Filing Date: 05/02/2001

Examiner: Brian K. Talbot

Art Unit: 1762

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Non-final Office Action dated March 13, 2006, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: